



# Radiation Hardened Pixel Development

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# Outline

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- **Introduction:** radiation effects
- **Total ionising dose effects ( $^{60}\text{Co}$  source)**
  - standard active pixels
  - solutions for total ionising dose hardening
    - pMOS based pixel
    - radiation-tolerant nMOS pixel
- **Proton-induced displacement damage (10 MeV protons)**
- **Latch-up experiments**
- **OISL pixel**
- **Conclusions**

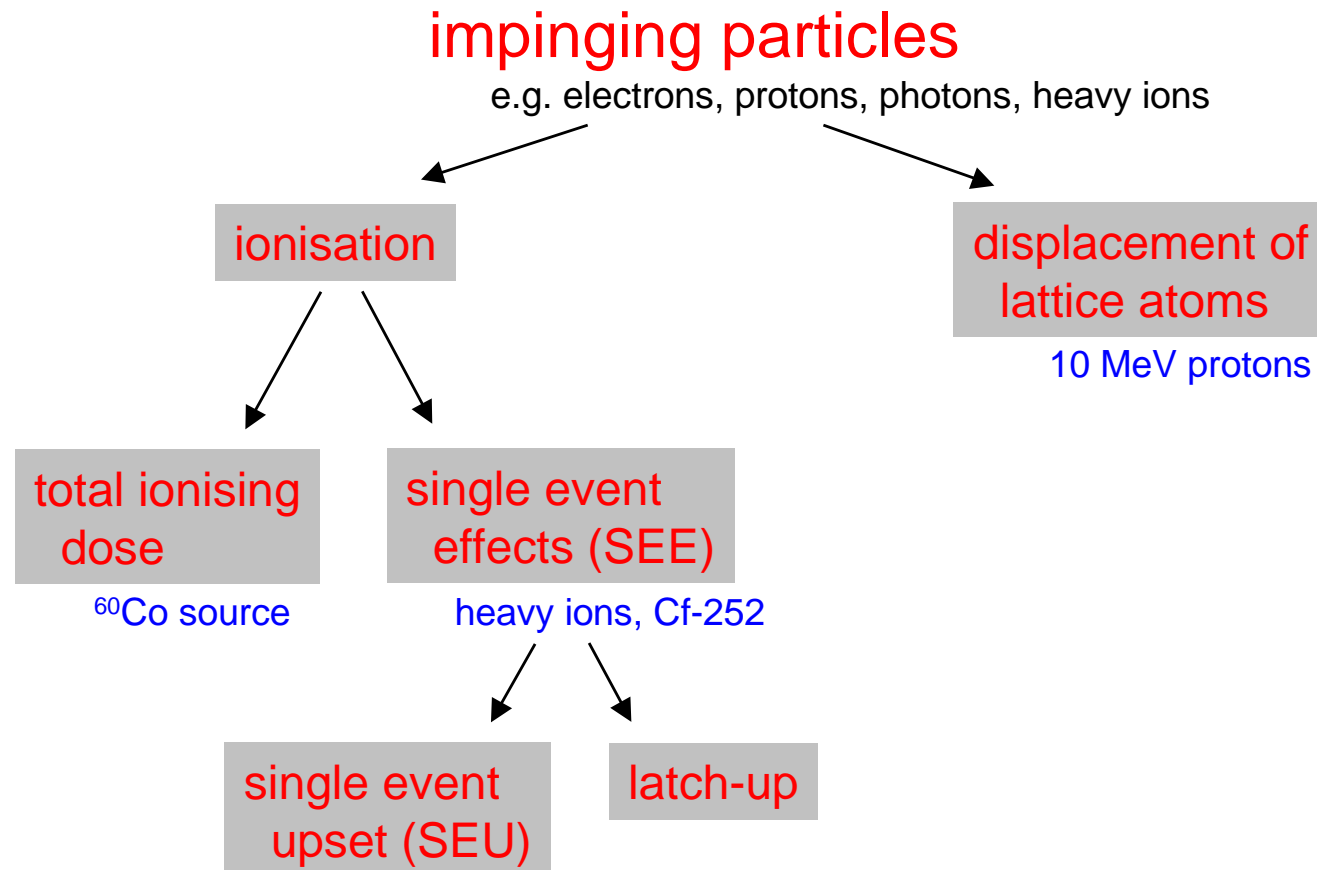


# Introduction

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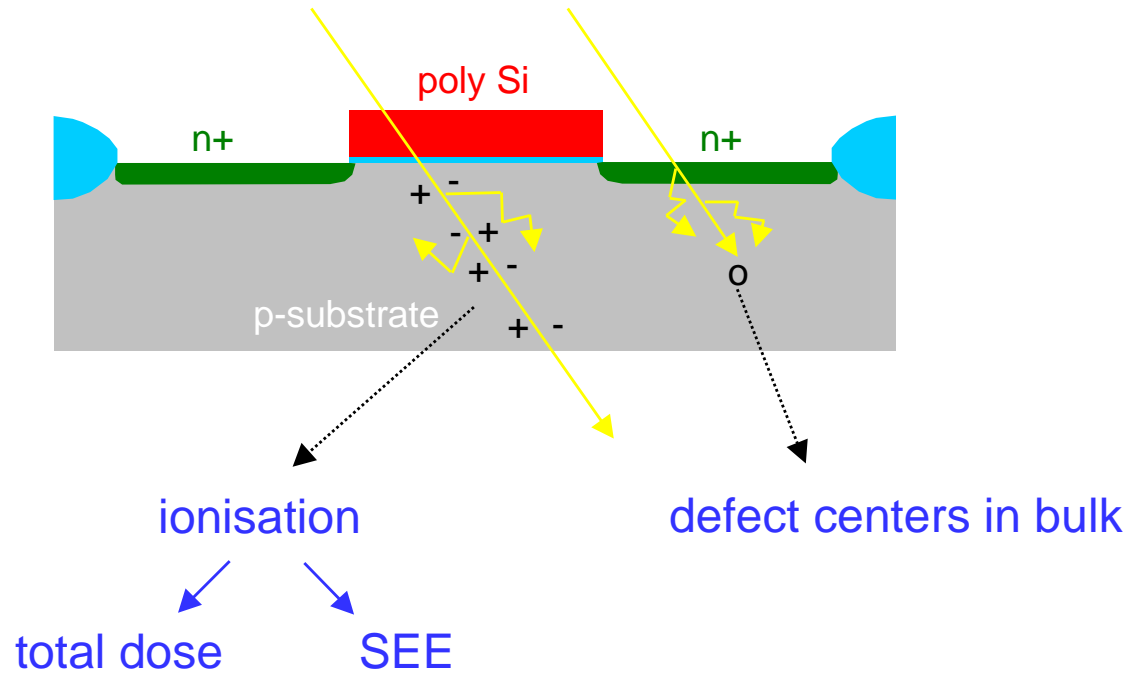
- **CMOS APS with CCD performance**
  - **Operation in the space radiation environment:**
    - **APS inherently more radiation tolerant than CCDs ?**
    - **other advantages: low power, on-chip integration, windowing, lower system cost, ...**
- ⇒ **study and improvement of radiation tolerance of APS**

# Basic radiation effects (1)



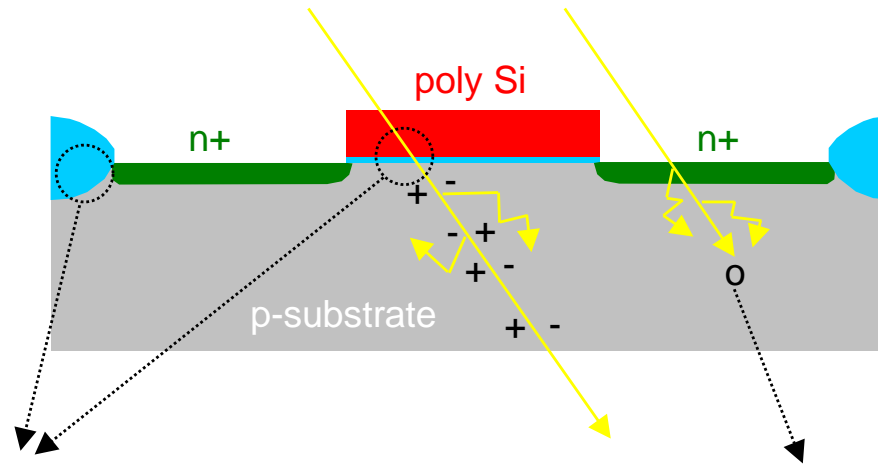
# Basic radiation effects (2)

MOS  
structure



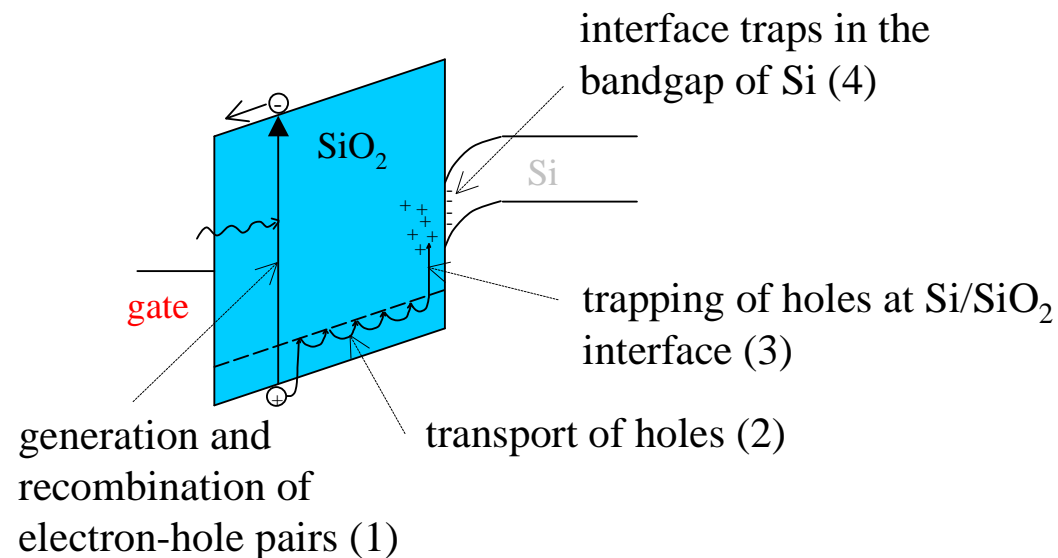
# Basic radiation effects (2)

MOS structure



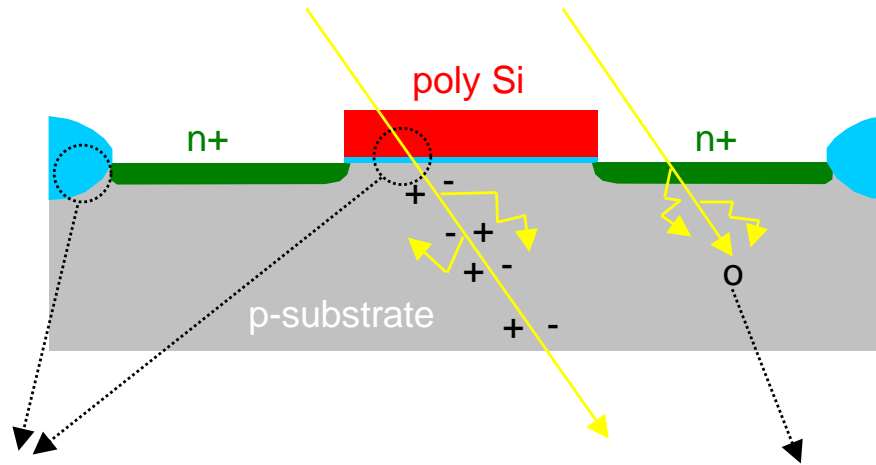
ionisation in oxides

defect centers in bulk



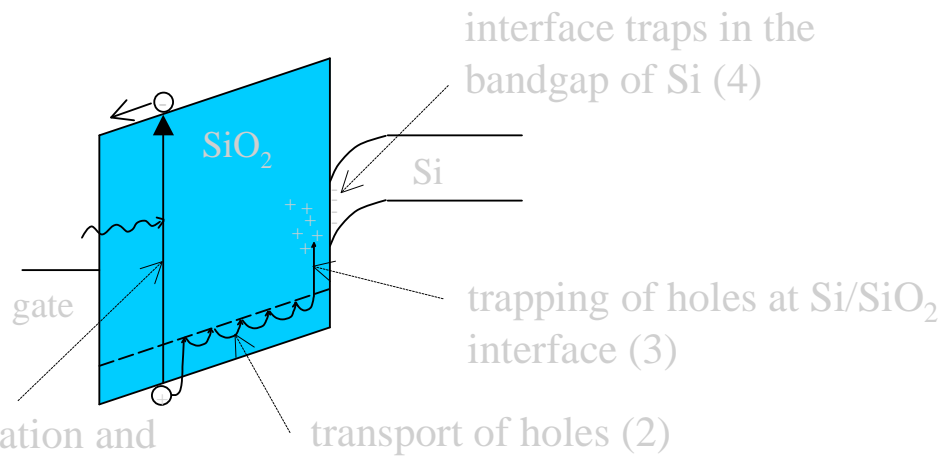
# Basic radiation effects (2)

MOS structure



ionisation in oxides

defect centers in bulk



generation and recombination of electron-hole pairs (1)

transport of holes (2)

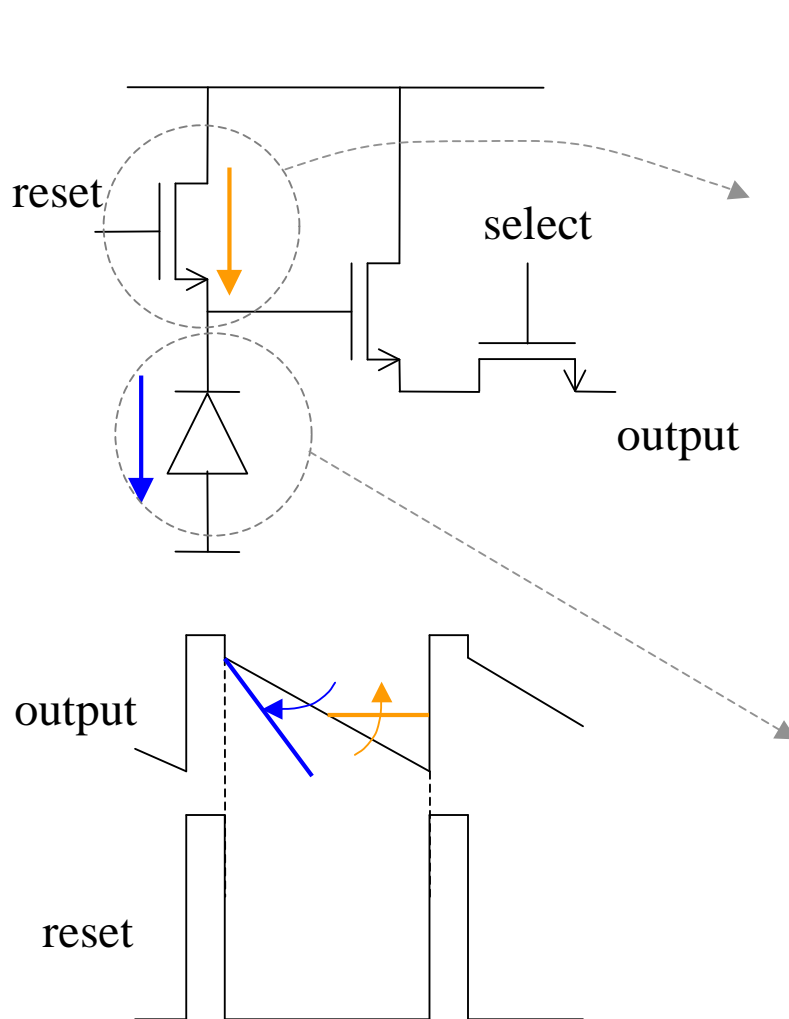
trapping of holes at Si/SiO<sub>2</sub> interface (3)

interface traps in the bandgap of Si (4)

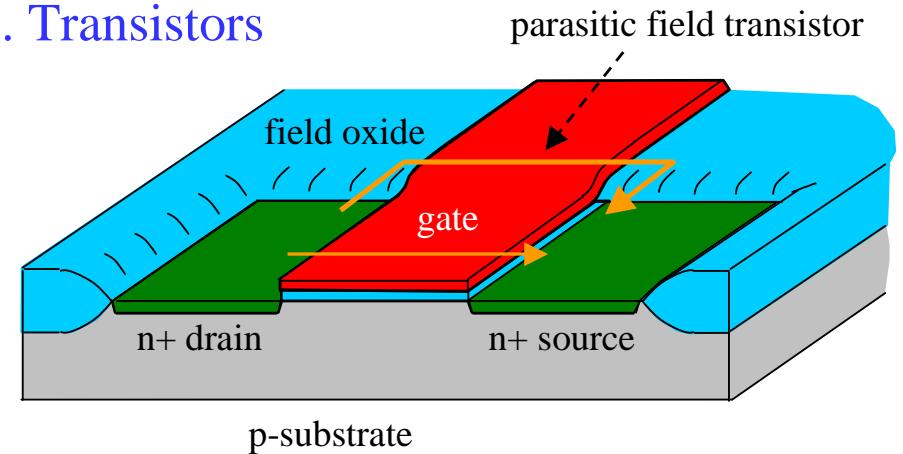
- ★ generation
- ★ recombination
- ★ trapping

# Total dose: standard active pixels

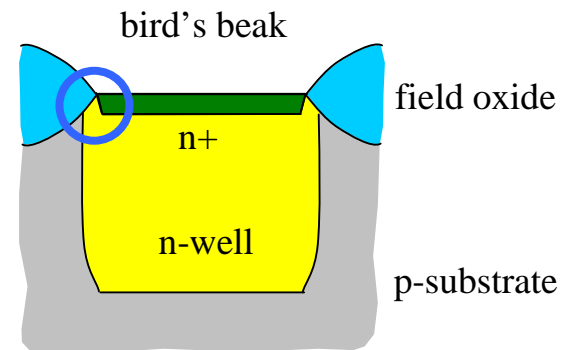
## Radiation induced surface damage



### 1. Transistors



### 2. Photodiode

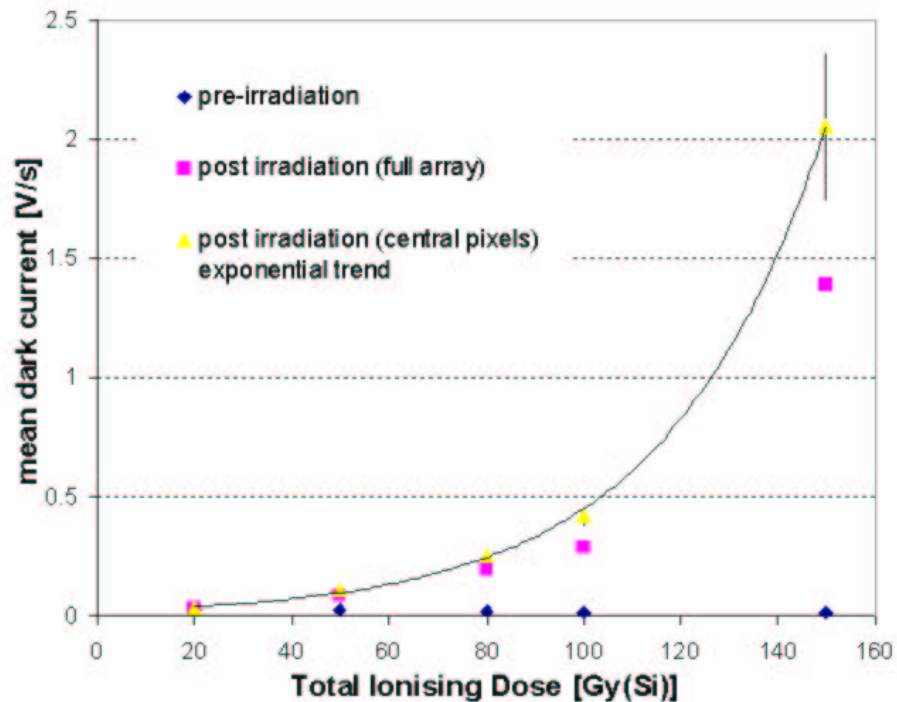


### 3. Interconnections

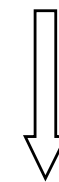


# Mean dark current increase

## Co-60 measurements on IRIS-2 chips



★ pre-irradiation value:  
± 20 mV/s

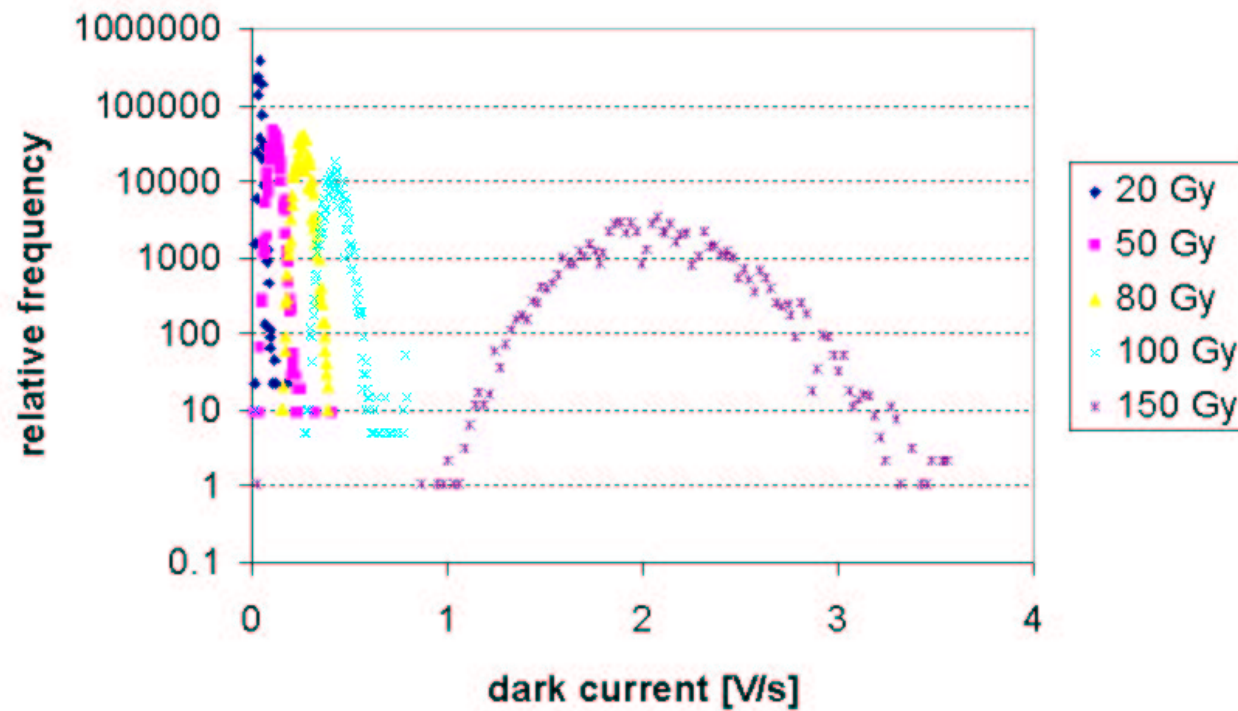


exponential  
dark current increase

★ post-irradiation value:  
150 Gy(Si): ± 2 V/s

# Dark current non-uniformity

## Co-60 measurements on IRIS-2 chips



dark current non-uniformity increases with total ionising dose

# Radiation-tolerant active pixels

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- **The pMOS based pixel**

- + no parasitic field transistors

- + area

- low sensitivity, fill factor

- **Radiation-tolerant nMOS pixel**

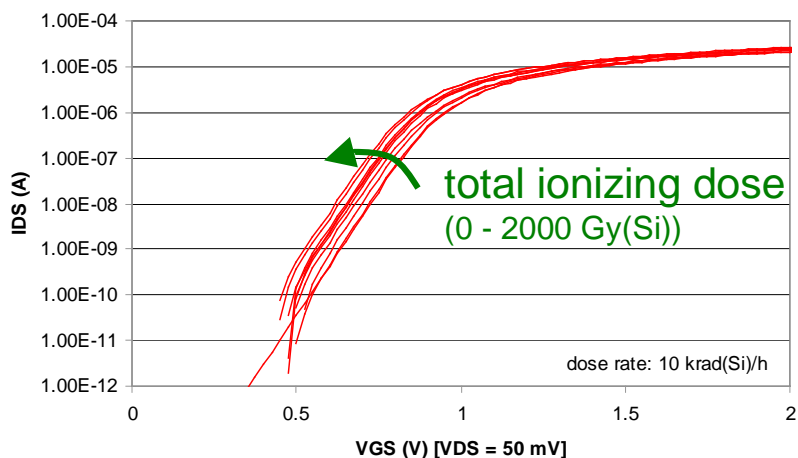
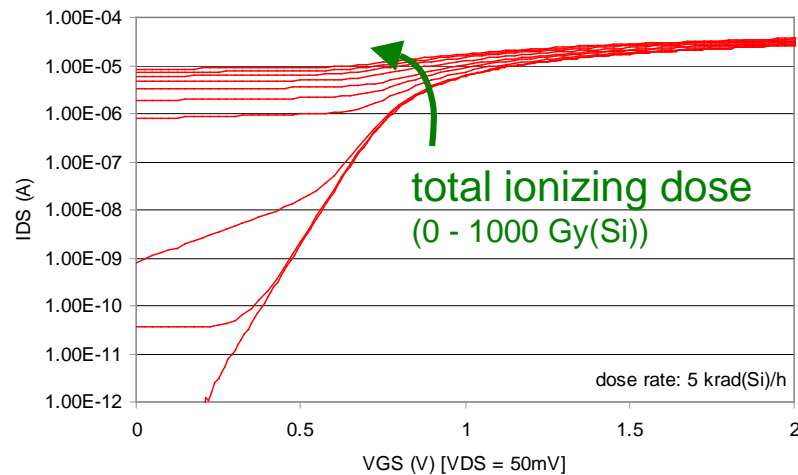
- TID tolerance: > 200 kGy(Si) (dose rate: 350 Gy(Si)/h)

- area:

technology	minimal pixel pitch
0.7 $\mu\text{m}$	20 $\mu\text{m}$
0.5 $\mu\text{m}$	15 $\mu\text{m}$
0.35 $\mu\text{m}$	8 $\mu\text{m}$

# Radiation-tolerant nMOS pixel

## Input characteristics of nMOS transistors



### Standard nMOS layout:

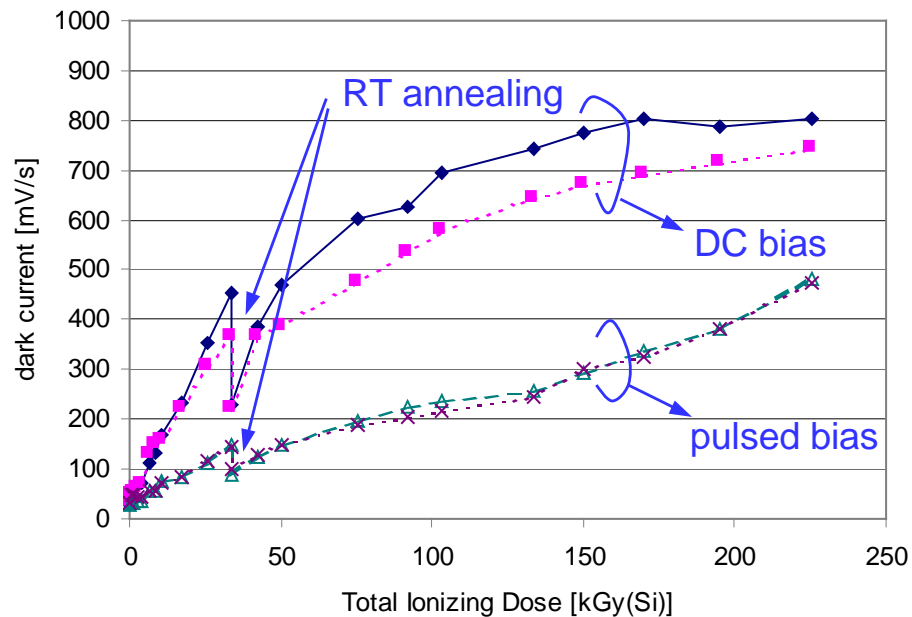
- large leakage current increase due to parasitic field transistor
- typical TID threshold: 200 - 400 Gy(Si)

### Radiation-tolerant nMOS layout:

- no leakage current increase
- small threshold voltage shift  
 $t_{\text{oxide}}$  dependence !

# Radiation-tolerant nMOS pixel

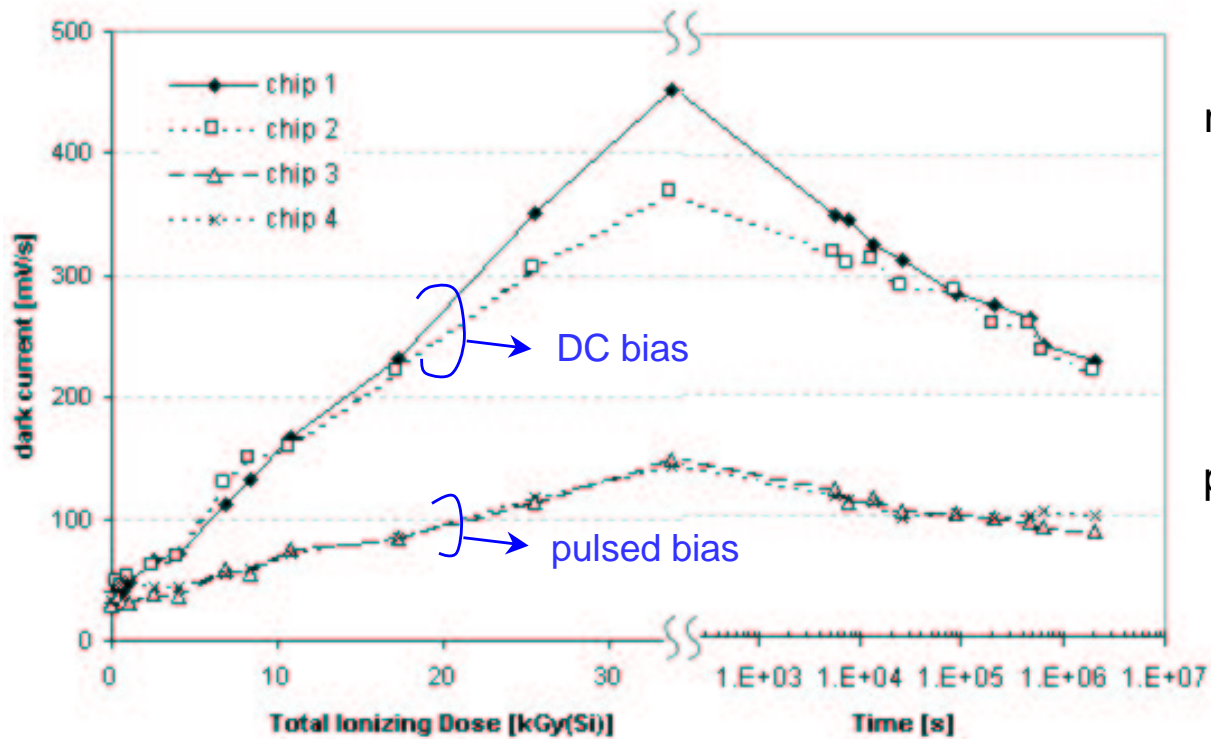
## Dark current of radiation-tolerant nMOS pixel (0.7 $\mu\text{m}$ technology)



- very low dark current increase compared to standard active pixels
- dark current radiation-tolerant nMOS pixel < dark current pMOS based pixel
- 'DC bias' is the worst case scenario

# Radiation-tolerant nMOS pixel

## Dark current of radiation-tolerant nMOS pixel



room temperature annealing:

- why?
- log(time) annealing



dark current increase is probably small in low dose rate space environment





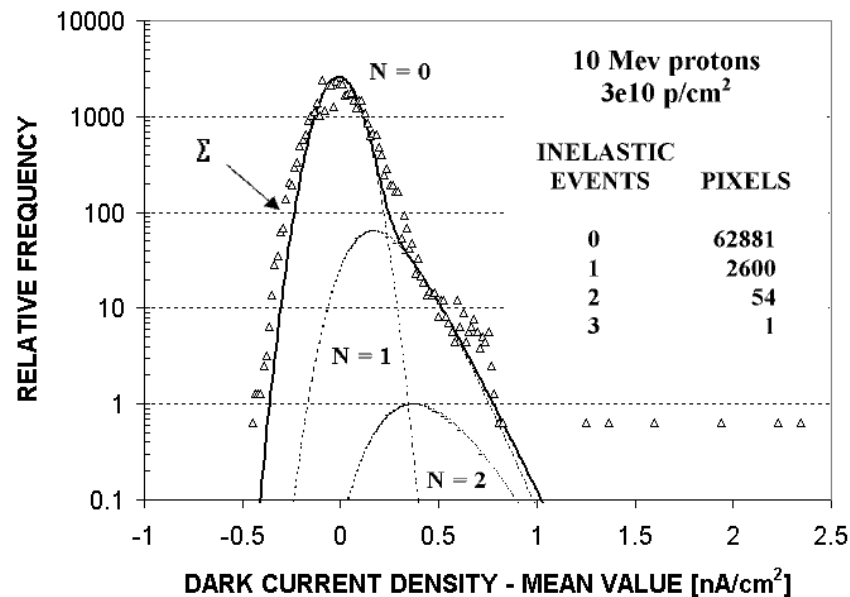
# Displacement damage (1)

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- **Devices:** 5 Ibis4 CMOS APS from FillFactory
- **Irradiation:** 10 MeV protons  
 $3 \times 10^9$ ,  $1 \times 10^{10}$ ,  $3 \times 10^{10}$ ,  $1 \times 10^{11}$ ,  $3 \times 10^{11}$  protons/cm<sup>2</sup>
- **Displacement damage effects:**
  - mean value and variance of the dark current density increase
  - distributions become more skewed
  - anomalously high dark current spikes:  
field-enhanced emission

# Displacement damage (2)

## Histogram of dark current density



- 256x256 window  
**3x10<sup>10</sup> protons/cm<sup>2</sup>** (10 MeV)
- pixel sensitive volume:  
**45 μm<sup>3</sup>**  
(typically 1000 μm<sup>3</sup> for CCDs, CIDs)
- elastic interactions:  
**416 per pixel**  
inelastic interactions:  
**0.138 per pixel**

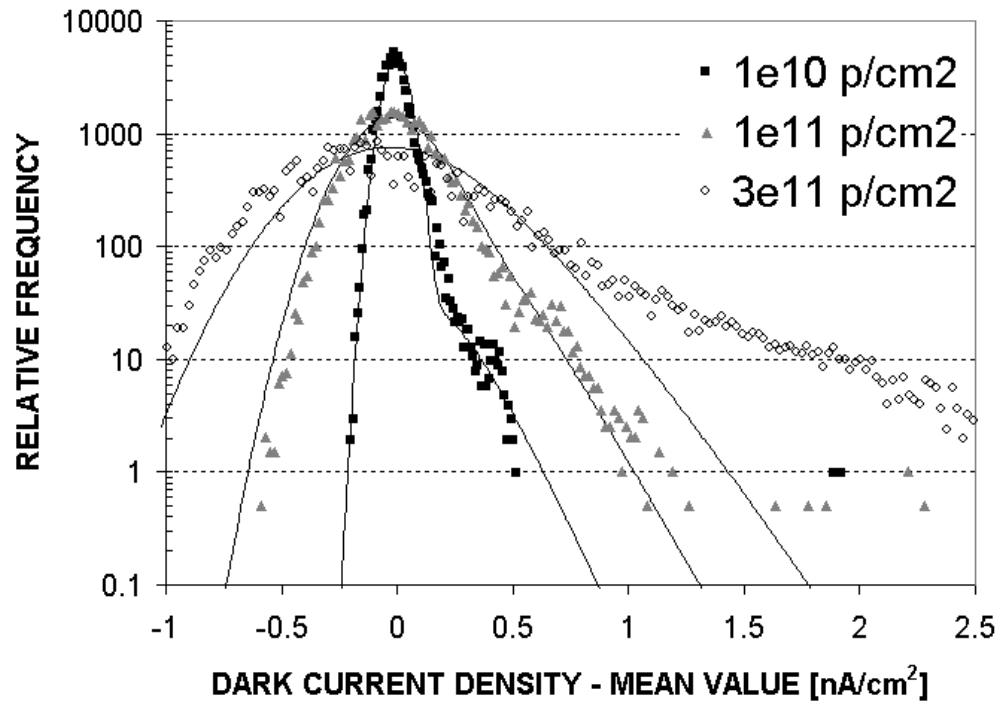
10 MeV proton recoil spectrum  
parameters (Marshall et al.) ⇒

Cross section (10 <sup>-24</sup> cm <sup>2</sup> )	Mean damage energy (MeV)	Variance of damage energy (MeV <sup>2</sup> )
ELASTIC EVENTS		
1847.5	1.784 x 10 <sup>-4</sup>	*4.77 x 10 <sup>-6</sup>
INELASTIC EVENTS		
0.6127	0.06021	1.30976 x 10 <sup>-3</sup>



# Displacement damage (3)

## Histogram of dark current density at different fluences

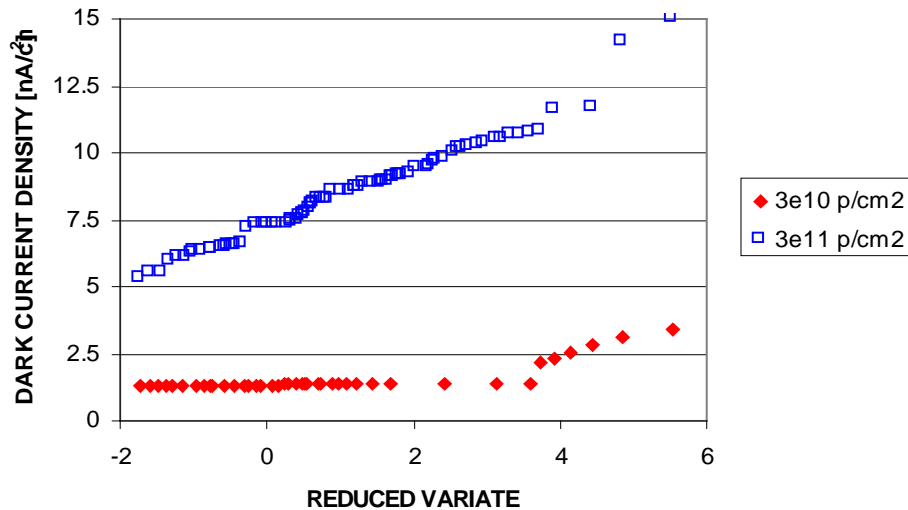


- mean value has a component due to ionisation damage
- mean value and variance of the dark current density increase with increasing proton fluence

### Tail on distributions:

- infrequent, highly damaging inelastic collisions
- spikes: field-enhancement

# Displacement damage (4)



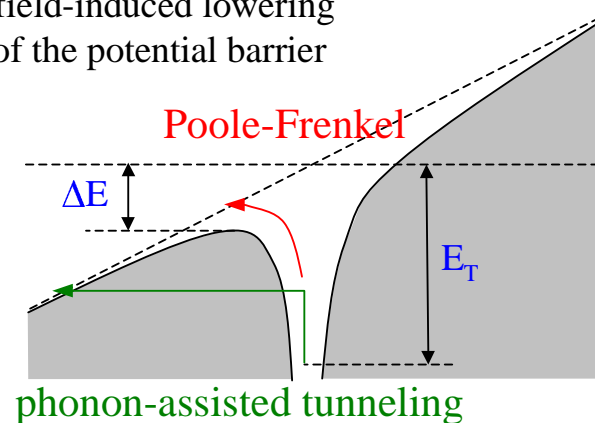
- 256 x 256 window subdivided: 256 bins of 256 pixels each
- extreme value statistics: largest dark current values do not follow the normal distribution



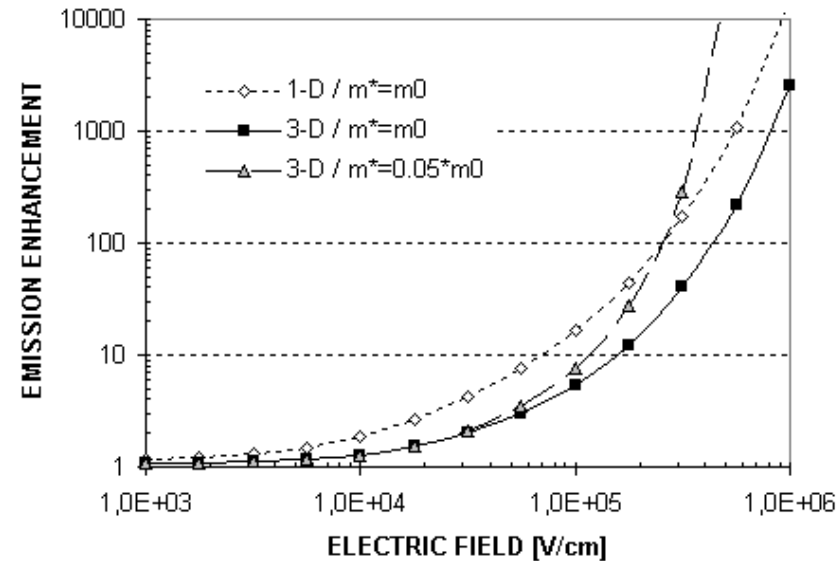
## FIELD-ENHANCED EMISSION

- Poole-Frenkel effect
- phonon-assisted tunneling

$E_T$  = energy level of the trap  
 $\Delta E$  = field-induced lowering of the potential barrier



# Displacement damage (5)



emission enhancement factor (Coulombic potential):

$\pm 10 @ 10^5 \text{ V/cm}$

- ✗ very small area in sensitive volume
- ✗ induced by other defect



# Latch-up experiments

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- **ASCoSS sensor (Sira, heavy ions)**

latch-up threshold     $\sim 19.9 \text{ MeV/mg/cm}^2$     (ADC)

$> 28 \text{ MeV/mg/cm}^2$     (analog core)

- **IRIS-2 (Cf-252)**

latch-up    (43 MeV/mg/cm<sup>2</sup>)    (only in digital core)



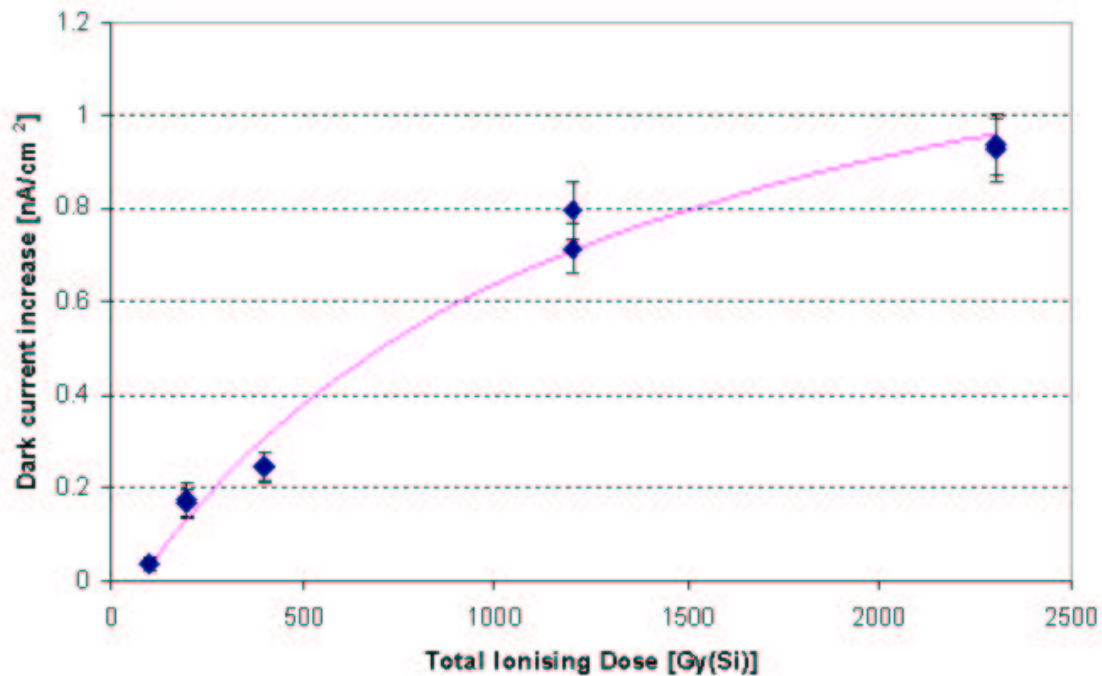
# OISL pixel

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- **OISL = CMOS Active Pixel Sensor  
for Optical Inter-Satellite Link**  
(details in presentation **D. Uwaerts, FillFactory**)
- **radiation-tolerant design:**
  - **0.5  $\mu\text{m}$  technology**
  - **$^{60}\text{Co}$  irradiation (50 Gy(Si)/h):**
    - 10 devices
    - total ionising dose: 100, 200, 400, 1200, 2300 Gy(Si)
    - ongoing irradiation >50 kGy(Si)

# Dark current density increase

## Co-60 measurements on OISL



★ pre-irradiation value:  
 $\pm 0.2 \text{ nA/cm}^2$   
 $(\pm 45 \text{ mV/s})$

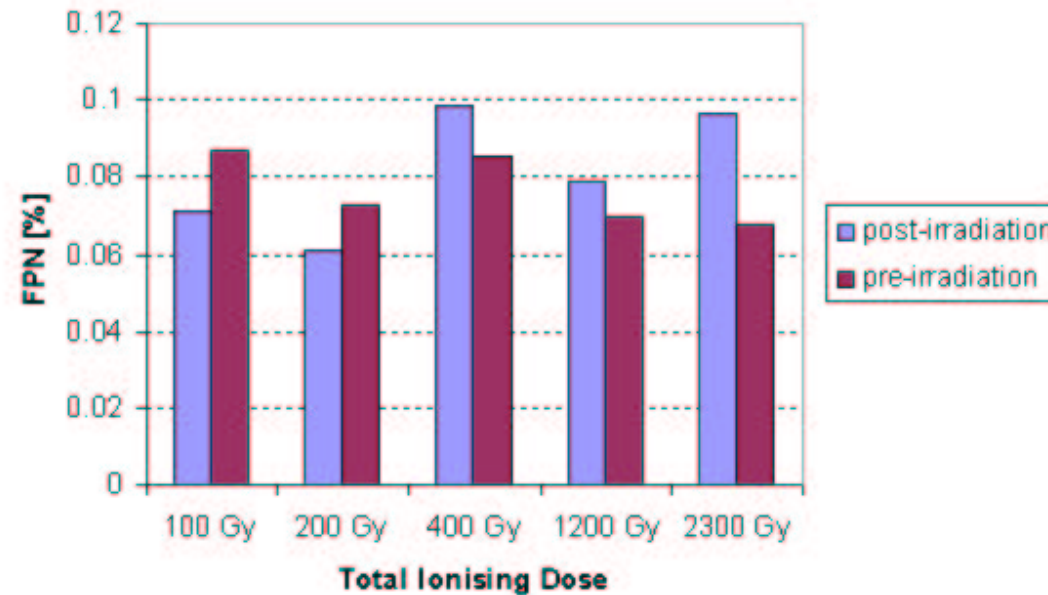


**saturating  
 dark current increase**

★ post-irradiation value:  
 2300 Gy(Si):  
 $\pm 1.1 \text{ nA/cm}^2$

# Fixed pattern noise

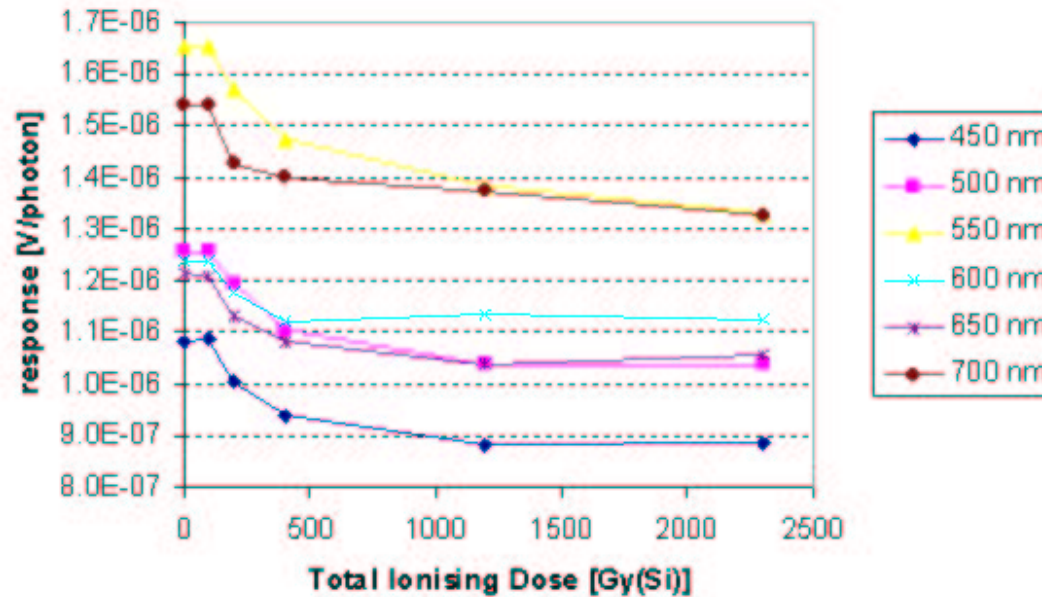
## Co-60 measurements on OISL



FPN not affected by Co-60 irradiation:  
no degradation in column amplifiers

# Photo-response

## Co-60 measurements on OISL



decrease of responsivity (wavelength dependent)

- increased absorption in overlaying layers?
- decrease of QE?



# After 20 kGy(Si) (2 Mrad(Si))!

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# Conclusions (1)

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- **Ionising radiation:**

- large impact at the surface in standard active pixels
  - nMOS leakage current
  - increase in dark current
- radiation tolerant pixels can be obtained ( $> 200$  kGy(Si))

- **Displacement damage:**

- mean and variance
- tail on histograms: - inelastic nuclear collisions
  - field-enhanced emission



## Conclusions (2)

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- **Comparison with CCDs**

- radiation tolerance in standard CMOS technology
- large operating window
- no problems with CTE
- mean dark current and amplitude of dark current spikes is lower:
  - ⇒ smaller sensitive volume

- **Design of OISL:**

**Probably the best radiation-tolerant CMOS imager in the world...**